

0163-0707-2X

**RESPONSE UNDER 37 C.F.R. §1.116 -
EXPEDITED PROCEDURE EXAMINING GROUP 1722**

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
Kenji MIWA et al : GROUP: 1722
SERIAL NO: 09/158,099 :
FILED: September 22, 1998 : EXAMINER: LIN, K.
FOR: METHOD OF REFINEMENT OF :
MICROSTRUCTURE OF...

AMENDMENT UNDER 37 C.F.R. §1.116

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Responsive to the Official Action mailed December 19, 2000, please amend the
above-identified patent application, as follows:

IN THE SPECIFICATION

Please amend the specification, as follows:

Page 11, line 11, ~~delete~~ the heading "Brief Description of the Drawings" in its
entirety.

IN THE CLAIMS

Please ~~cancel~~ Claims 11-14, without prejudice or disclaimer.

Please ~~add~~ new Claims 15-18, corresponding to subject matter from Claims 11-14, as
follows:

15. (New) A method for ~~refining~~ a microstructure of a metallic material, comprising:

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(J.E.)
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